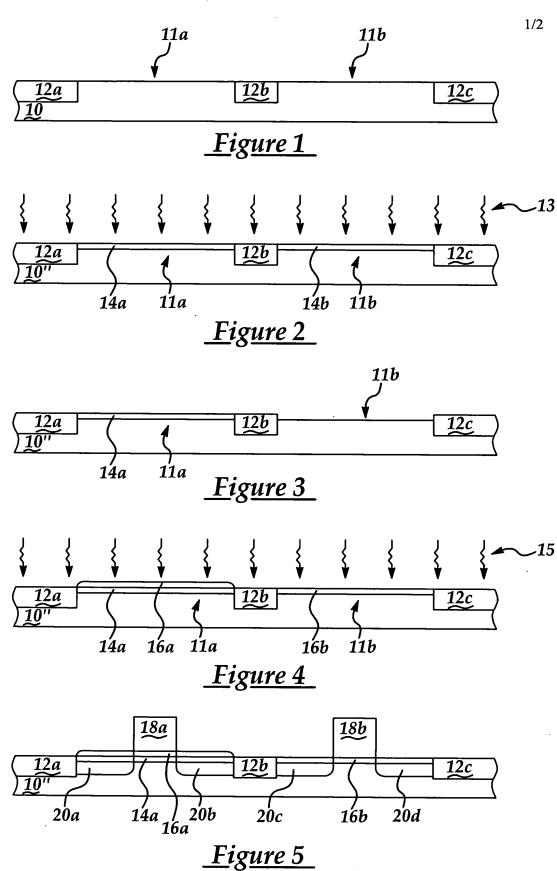
Inventor: CHING-CHEN HAO

Serial No.: To Be Assigned Filed: Herewith

For: HALOGEN GETTERING METHOD FOR FORMING FIELD EFFECT TRANSISTOR (FET)

DEVICE

Attorney Doc. No.: 67,200-1071

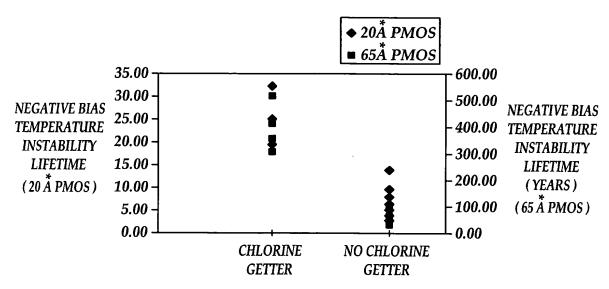


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FIRST THERMAL OXIDIZING ATMOSPHERE COMPOSITION

Figure 6

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